



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : YEH
Application No. : 10/601,701
Filed : June 24, 2003
Title : METHOD FOR FABRICATION OF POLYCRYSTALLINE
SILICON THIN FILM TRANSISTORS
Group Art Unit : 2812
Examiner : S. Isaac
Docket No. : 3230-56

MAIL STOP AMENDMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL COVER SHEET

Sir:

Transmitted herewith for filing are the following:

1. AMENDMENT - in response to Notice of Non-Compliant Amendment of April 6, 2006.

The Commissioner is hereby authorized to charge any fees which may be required for the filing of this document to Deposit Account No. 501874.

Respectfully submitted,

Date: May 3, 2006

By:


Bruce H. Troxell
Reg. No. 26,592

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Attorney Docket: BHT/3230-56

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RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In response to the Office Action of April 6, 2006, please amend the
above-identified application as follows: